

L Number	Hits	Search Text	DB	Time stamp
28	34410	diffractions adj5 grating	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/07/21 11:39
29	8393	DOE	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/07/21 11:39
30	23056	anti-reflective\$4	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/07/21 11:40
31	18245	antireflective\$4	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/07/21 11:40
32	273	(diffractions adj5 grating) same anti-reflective\$4	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/07/21 11:40
33	268	(diffractions adj5 grating) same antireflective\$4	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/07/21 11:40
34	523	((diffractions adj5 grating) same anti-reflective\$4) or ((diffractions adj5 grating) same antireflective\$4)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/07/21 13:30
35	266	diffractions adj5 facets	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/07/21 13:32
36	2	anti-reflective\$4 same (diffractions adj5 facets)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/07/21 13:33
37	7	antireflective\$4 same (diffractions adj5 facets)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/07/21 13:33
38	9	(anti-reflective\$4 same (diffractions adj5 facets)) or (antireflective\$4 same (diffractions adj5 facets))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/07/21 13:41
39	1	("5113286").PN.	USPAT	2004/07/21 14:08
40	92451	grating	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/07/21 14:08
41	181839	relief	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/07/21 14:08

42	39	anti-reflecti\$4 with relief	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/07/21 14:08
43	92	antireflecti\$4 with relief	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/07/21 14:08
44	130	(anti-reflecti\$4 with relief) or (antireflecti\$4 with relief)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/07/21 14:26
45	2935	"AR" adj5 coat\$4	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/07/21 14:26
46	662	359/569[ccls]	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/07/21 14:26
47	891	359/566[ccls]	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/07/21 14:27
48	156	359/576[ccls]	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/07/21 14:27
49	1478	359/569[ccls] or 359/566[ccls] or 359/576[ccls]	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/07/21 14:27
50	17	("AR" adj5 coat\$4) and (359/569[ccls] or 359/566[ccls] or 359/576[ccls])	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/07/21 14:28
51	97	anti-reflecti\$4 and (359/569[ccls] or 359/566[ccls] or 359/576[ccls])	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/07/21 14:28
52	67	antireflecti\$4 and (359/569[ccls] or 359/566[ccls] or 359/576[ccls])	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/07/21 14:28
53	147	((("AR" adj5 coat\$4) and (359/569[ccls] or 359/566[ccls] or 359/576[ccls])) or (anti-reflecti\$4 and (359/569[ccls] or 359/566[ccls] or 359/576[ccls]))) or (antireflecti\$4 and (359/569[ccls] or 359/566[ccls] or 359/576[ccls])))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/07/21 14:28
54	143	((("AR" adj5 coat\$4) and (359/569[ccls] or 359/566[ccls] or 359/576[ccls])) or (anti-reflecti\$4 and (359/569[ccls] or 359/566[ccls] or 359/576[ccls]))) or (antireflecti\$4 and (359/569[ccls] or 359/566[ccls] or 359/576[ccls]))) not ((anti-reflecti\$4 with relief) or (antireflecti\$4 with relief))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/07/21 15:36

55	429312	dielectric	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/07/21 15:36
56	3371	anti-reflecti\$4 same dielectric	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/07/21 15:36
57	2049	antireflecti\$4 same dielectric	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/07/21 15:41
58	5076	(anti-reflecti\$4 same dielectric) or (antireflecti\$4 same dielectric)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/07/21 15:41
59	910	directional adj5 deposit\$5	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/07/21 15:41
60	1	((anti-reflecti\$4 same dielectric) or (antireflecti\$4 same dielectric)) same (directional adj5 deposit\$5)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/07/21 15:42
61	36	((anti-reflecti\$4 same dielectric) or (antireflecti\$4 same dielectric)) and (directional adj5 deposit\$5)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/07/21 15:45
62	132	dielectric same (directional adj5 deposit\$5)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/07/21 15:45
63	123	(dielectric same (directional adj5 deposit\$5)) not (((anti-reflecti\$4 same dielectric) or (antireflecti\$4 same dielectric)) and (directional adj5 deposit\$5))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/07/21 15:47
64	1	(directional adj5 deposit\$5) same anti-reflecti\$4	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/07/21 15:47
65	2	(directional adj5 deposit\$5) same antireflecti\$4	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/07/21 15:47
66	0	(directional adj5 deposit\$5) same ("AR" adj5 coat\$4)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/07/21 15:47
67	3	((directional adj5 deposit\$5) same anti-reflecti\$4) or ((directional adj5 deposit\$5) same antireflecti\$4)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/07/21 15:48
68	38144	anti-reflecti\$4 or antireflecti\$4 or ("AR" adj5 coat\$4)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/07/21 15:48

69	5403	"CVD" with evaporation	USPAT; US-PPGPUB; EPO; JPO; DERWENT; IBM TDB	2004/07/21 15:49
70	4210	("CVD" with evaporation) same sputter\$3	USPAT; US-PPGPUB; EPO; JPO; DERWENT; IBM TDB	2004/07/21 15:49
71	44	(anti-reflecti\$4 or antireflecti\$4 or ("AR" adj5 coat\$4)) same ((("CVD" with evaporation) same sputter\$3)	USPAT; US-PPGPUB; EPO; JPO; DERWENT; IBM TDB	2004/07/21 16:00
72	12	(directional adj5 deposit\$5) same ((("CVD" with evaporation) same sputter\$3)	USPAT; US-PPGPUB; EPO; JPO; DERWENT; IBM TDB	2004/07/21 16:11
73	1	("5853960").PN.	USPAT	2004/07/21 16:11
74	1	("5055319").PN.	USPAT	2004/07/21 16:12
75	1	("4989972").PN.	USPAT	2004/07/21 16:25
76	319944	semiconduct\$5	USPAT	2004/07/21 16:25
77	91123	quartz	USPAT	2004/07/21 16:25
78	712	semiconduct\$5 adj4 quartz	USPAT	2004/07/21 16:27
79	245835	silica	USPAT	2004/07/21 16:27
80	104923	"SiO.sub.2"	USPAT	2004/07/21 16:27
81	1056	semiconduct\$5 adj4 "SiO.sub.2"	USPAT	2004/07/21 16:28
82	297	semiconduct\$5 adj2 "SiO.sub.2"	USPAT	2004/07/21 16:28